



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shunpei Yamazaki, et al. Art Unit : 2818
Serial No. : 10/033,100 Examiner : Renee Berry
Filed : October 25, 2001
Title : FILM FORMATION APPARATUS AND FILM FORMATION METHOD

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR ACKNOWLEDGEMENT OF PRIORITY
DOCUMENT UNDER 35 U.S.C. §119

Responsive to Notice of Allowance, Applicants hereby confirm their claim of priority under 35 USC §119 from the following application:

JAPAN 2000-326278, FILED OCTOBER 26, 2000

A certified copy of the application from which priority is claimed was submitted in the Utility Application on October 25, 2001. A copy of the cover page and date-stamped postcard identifying receipt in the U.S. Patent & Trademark Office is enclosed as evidence of the same.

It is respectfully requested that the Examiner acknowledge priority claim and receipt of the same. Note, applicants must pay the issue fee by May 3, 2004, so the examiner's prompt attention to this matter would be appreciated.

Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Roberto J. Devoto
Reg. No. 55,108

Date: April 29, 2004

Customer No. 26171
Fish & Richardson P.C.
1425 K Street, N.W., 11th Floor
Washington, DC 20005-3500
Telephone: (202) 783-5070
Facsimile: (202) 783-2331

日本国特許庁
JAPAN PATENT OFFICE

COPY

別紙添付の書類に記載されている事項は下記の出願書類に記載されて
いる事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed
with this Office

出願年月日

Date of Application:

2000年10月26日

出願番号

Application Number:

特願2000-326278

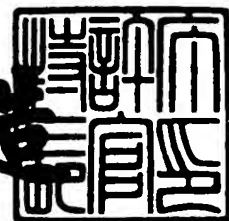
出願人
Applicant(s):

株式会社半導体エネルギー研究所

2001年 8月24日

特許庁長官
Commissioner,
Japan Patent Office

及川耕造



出証番号 出証特2001-3075511